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IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re United States Patent Application of:	)	Docket No.:	2771-594-CIP
Applicants: WANG, Ziyun, et al.	)	Conf. No.:	1841
Application No.: 10/699,079	)	Art Unit:	1621
Date Filed: November 14, 2002	)	Examiner:	Samuel A. Barts
Title: COMPOSITION AND METHOD FOR LOW TEMPERATURE DEPOSITION OF SILICON- CONTAINING FILMS	)	Customer No.:	

23448

FACSIMILE TRANSMISSION CERTIFICATEATTN: Examiner Samuel A. Barts

Fax No. (571) 273-8300

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12  
Number of Pages

  
Kate Pope

May 22, 2007  
Date

**REQUEST FOR CONTINUED EXAMINATION AND ACCOMPANYING  
AMENDMENT AND RESPONSE TO MARCH 22, 2007 FINAL OFFICE ACTION IN  
U.S. PATENT APPLICATION NO. 10/699,079**

Mail Stop RCE  
Commissioner for Patents  
P.O. Box 1450  
Alexandria, Virginia 22313-1450

Sir:

In response to the March 22, 2007 Final Office Action in the above-referenced application,

**2771-594-CIP**

applicants herein submit a Request for Continued Examination and this accompanying submission. Please enter this Amendment and Response into the file of the above-identified application

Please amend the claims of the above-identified patent application as set out in **Section I (Amendments to the Claims)** hereof.

Remarks concerning the amendments of the claims and the substance of the March 22, 2007 Office Action are set out in **Section II (Remarks)** hereof.